



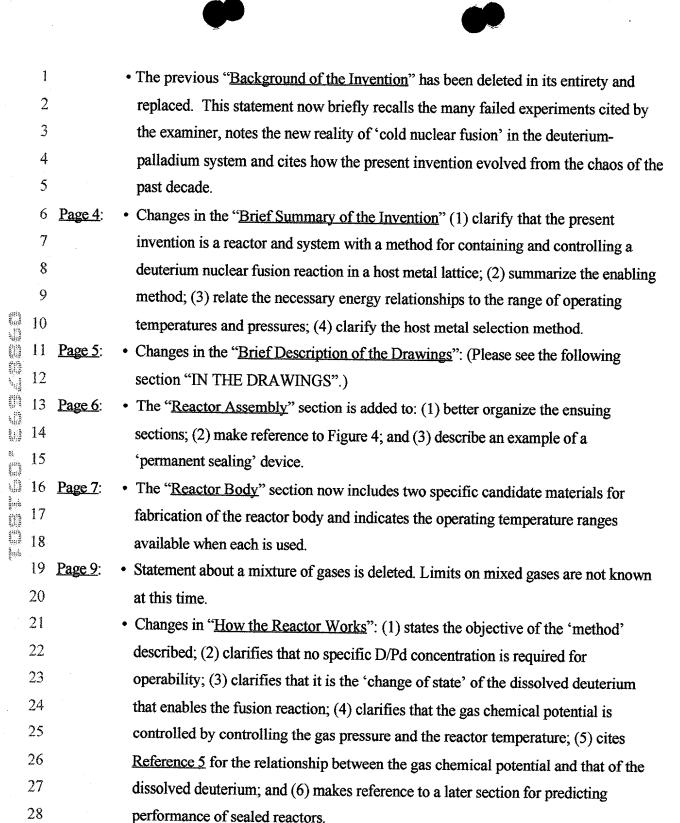


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2	A malicant	Waisman at al		G	
3	Applicant:	Waisman, et al CIP-1 09/348,142		Group Art 3641	
4	Filed:	07/02/99		Examiner: Behrend	
5	For:	Deuterium Heat Gene	erator	9	
6				/-	
7 8	THE H	ONORABLE COMM	ISSIONER OF PATENT	S AND TRADEMARKS	
9			Washington D. C.	7.	
10			RECEIVED	Santa Ana, California	
11			"LOCIVED	September 17, 2001	
12			SEP 2 1 2001		
13 14					
	Dear Sir:	٤	0 3600 MAIL ROOM		
15					
16		AMENDMENT	AS A CONTINUATION	N IN PART	
17					
18	In respor	use to the Office action	n of April 18 2001 we su	hmit CIP-2 Conject of new	
. 19	In response to the Office action of April 18, 2001, we submit CIP-2. Copies of new References 5 & 6 are enclosed.				
20		o are enerosea.			
21	IN THE SPECI	ETC A TION.			
22	in the site of	ITICATION.			
	**** 1				
23	We submit an amended Specification and a marked-up version of the old Specification,				
24	including claims, noting deletions, changes and additions. This amendment is made in response				
25	to the Examiner's comments in the Office Action letter pertaining to inadequacies in the old				
26	Specification. 7	The changes and the re	asons for each change are	noted below. The page numbers	
27	noted below ref	er to the "marked-up"	version of our pending ap	plication and to the 'first' page	
28	of a noted change	ge.		, <del>,</del> ,	
29					
30	Page 1: • Ref	Ference 3 is deleted. N	o longer referred to in the	Specification.	
31			call for an updated version	_	
32				replicating four successful	
33					
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<u>Page 10</u>: • Changes in the "<u>Chemical Potential</u>" section: (1) cites <u>Reference 5</u> for the derivation of chemical potential and its meaning in terms of the 'system free energy state'; (2)

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İ		clarifies that the method for selecting host metals is by conducting screening tests in		
2		a 'scanning reactor' to measure the threshold chemical potential of a candidate host		
3		metal; (4) describes the method of determining the relationship between operating		
4		chemical potential and the power density for a selected candidate host metal; (5)		
5		describes the necessary qualities of the scanning reactor and its operating range.		
6	Page 13: •	Adds "Host Metal Installation" section which cites three candidate method of		
7		installing the host metal in the reactor body. (Applicable text from "Host Metal"		
8		section on Page 8 has been incorporated here.)		
9	Page 14:	· Change to "System Control" section cites the reaction heat rate as being an		
10		exponential function of temperature.		
11	Page 15:	• Adds "Control of the Sealed Reactor" section that clarifies that increasing the heat		
12		rate of the sealed reactor is by increasing the operating chemical potential. It cites		
13		the need to predict the internal pressures as the temperature is increased so that the		
14		operating chemical potentials may then be predicted and matched to the host metal		
15		heat rate characteristics.		
16	Page 15:	• Adds the title "Predicting the Performance of Sealed Reactors" to the unchanged		
17		text from the old Specification.		
18	Page 17:	• Adds "Useful Life of the Sealed Reactor" section to explain (1) how the deuterium		
19		depletion takes place, (2) how it affects the heat rate and (3) the necessary		
20		corrective measures to extend the useful life of the sealed reactor.		
21	Page 18:	• Minor changes to (1) correct references to the enabling heater added to Figures 1 &		
22		2 and (2) to cite an alternate procedure when the selected loading temperature is too		
23		low.		
24	Page 20:	• The procedure for increasing the operating temperature of a sealed reactor is added.		
25				
26	IN THE D	RAWINGS:		
27				
28	Figure 1 is changed to show the enabling heater.			
29	Figure 2 is added to depict a typical reactor with fins for heat transfer.			

30 Figure 3 was Figure 2.

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- 1 Figure 4 is added to show a typical alternate location for the host metal.
- 2 Figure 5 was Figure 3.
- 3 Figure 6 is added to show the arrangement of the 'scanning' reactor.
- 4 Figure 7 is added to visualize the broad operating range of the present invention.
- Figure 8 is added to incorporate the "D-Pd TCP Equilibrium Diagram" into the Specification
- 6 rather than relying on Reference 4 to show the equilibrium data.
- 7 Figure 9 is added to show experimental data in terms of power density.

9 IN THE CLAIMS:

11 Claim 1 is modified to add reference to 'elevated system free energy states' for dependent claims

- of methods.
- 13 Claim 2 was deleted by an earlier amendment.
- 14 Claim 3 is modified to correct the format of the claim and to delete an unnecessary statement.
- 15 Claim 4 is modified to correct the format of the claim.
- 16 Claims 5 through 16 are unchanged.
- 17 Claim 17 is deleted since the 'deposited form' is a 'solid' form of the host metal and therefore is
- covered by claim 19.
- 19 Claims 20 claims the method of operating the system of claim 1.
- 20 Claims 21 claims the method of operating the system of claim 3.
- 21 Claim 22 claims the system for measuring the threshold chemical potential and the heat rate of
- 22 the host metal.
- 23 Claim 23 claims the method of producing high deuterium chemical potentials using the system of
- 24 claim 22.
- 25 Claim 24 claims the method for measuring the threshold chemical potentials of candidate host
- 26 metals using the system of claim 22.
- 27 Claim 25 claims the method for measuring the heat generation rates of the candidate host metals
- using the system of claim 22.
- 29 Claim 26 claims the method of generating heat using the system of claim 1.
- 30 Claim 27 claims the method of generating heat using the system of claim 3.

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2	The claims are presented in the new and the marked-up versions attached.				
3					
4	For purposes of examination: (1) claims 1, 3, 4, and 18 through 27 read on palladium as				
- 5	the elected ultimate host metal; (2) claims 1, 3 through 16 and 20 through 27 read on powder as				
6	the elected ultimate form of host metal. Note that we now elect the 'powdered' form as the				
7	ultimate form of the host metal instead of the 'deposited' form.				
8					
9	REMARKS				
10					
10 11 11 11 11 12	Remarks about the examiner's comments in the Office action letter are enclosed along				
	with 12 enclosures. It is recommended that the Examiner read Enclosure 5 "This Invention vs				
13	Prior Art" before starting the examination to save time.				
@14					
CI #	Para (C. II 1 . 1 . 1 . 1				
16 17	Respectfully submitted,				
118	Harle Frie				
H9	Frank C. Price				
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